L Number	Hits	Search Text	DB	Time stamp
1	54119	semiconductor and cmos	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/07/11 13:38
2	1099	(semiconductor and cmos) and (work adj function)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/07/11 13:39
3	792	((semiconductor and cmos) and (work adj function)) and (gate adj electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/07/11 13:39
4	217	(((semiconductor and cmos) and (work adj function)) and (gate adj electrode)) and (titanium adj nitride) and titanium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/07/11 13:40

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